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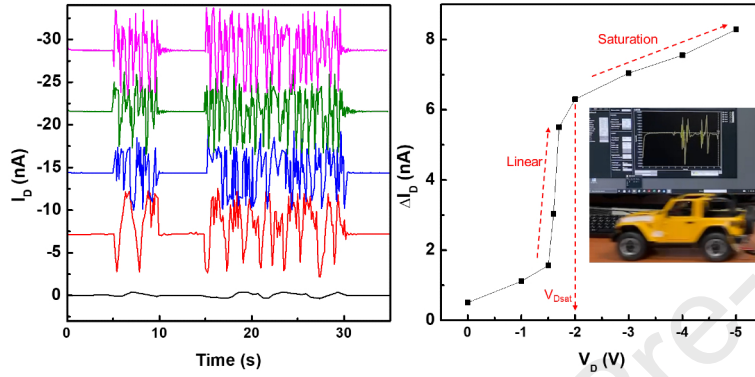
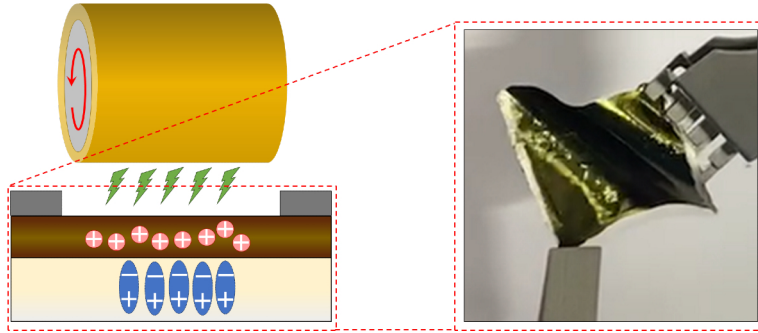
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# Energy-efficient Electronics with an Air-friction-driven Rotating Gate Transistor using Tribotronics

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## SUMMARY

Concern for the environment is one of the main factors that are increasing the demand for compact and energy-efficient electronic devices. Recent research has made advances in reducing the power consumption of field-effect transistors, including the use of high-dielectric insulators, low-voltage operation, and selective power-conservation strategies. This paper introduces a revolutionary air-friction-driven rotating gate transistor that operates without the need for a conventional gate voltage. This new device offers the advantages of wear resistance, a slim and flexible design (achieved through low-temperature solution processing), and a simplified three-layer structure that streamlines manufacturing and reduces potential carbon emissions. This device's wear resistance and ease of fabrication render the device a promising technology with applications in various fields, including electronics, vehicles, aviation, and wearable devices. This study provides evidence of the device's feasibility for use in real-world vehicular scenarios, underscoring its potential for future innovation and widespread adoption.

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## INTRODUCTION

Field effect transistors (FETs) have been employed extensively in the field of flexible electronic devices, which encompasses biosensors and chemical sensors,<sup>1,2</sup> displays,<sup>3</sup> and memory modules.<sup>4,5</sup> These technological advancements have significantly increased the deployment of FETs various fields while simultaneously expediting the evolution of intelligent systems and wearable technologies. Moreover, the electronics domain is demanding increasing integration into compact form factors, with a concurrent emphasis on power efficiency, which has increased in recent years.<sup>6-8</sup> From an environmental perspective, the drive to reduce greenhouse gas emissions and transition toward sustainable energy is increasing within the electronics field. Industry-wide, a concerted focus exists on reducing carbon footprints, with research and development efforts actively contributing toward this goal.<sup>9-12</sup> Recent contributions to the achievement of this goal have included the introduction of an insulator with a high dielectric constant and a FET that operates at voltages as low as 2 V, which was reported by Tetzner et al.<sup>13</sup> Furthermore, the fundamental power consumption of FETs has been minimized, with a subthreshold slope as low as 65 mV/decade owing to the use of high-purity rubrene single crystals, as demonstrated by Blülle et al.<sup>14</sup> Moreover, Jo et al.<sup>15</sup> introduced a selective scan driver and presented a circuit configuration aimed at conserving power that would otherwise be wasted. In addition to these studies, research with a distinct emphasis on low-power-consumption FETs has recently increased.<sup>16-19</sup>

Phototransistors offer an alternate route to achieving energy efficiency by harnessing sustainable light energy.<sup>20-24</sup> However, similar to solar cells, the efficiencies of most phototransistors decrease with increasing temperature, resulting in increased leakage current and decreased energy yield. Ongoing research is attempting to mitigate these thermal losses without using extensive cooling systems or heat-load management.<sup>25-28</sup> Furthermore, this research direction has resulted in an innovative paradigm shift in which the traditional gate voltage ( $V_G$ ) in FETs has been supplanted by voltage sourced directly from triboelectric nanogenerators (TENGs) to significantly reduce power consumption.<sup>29-38</sup> These systems are attractive due to their eco-friendly promise of harnessing electrical energy from wasted ambient mechanical energy.<sup>39</sup> However, the FET's reliance on TENGs for supplying the  $V_G$  necessitates an additional component, which complicates the fabrication process and deviates from the trend of miniaturization. The rotating gate transistor presented by Shin et al.<sup>40</sup> addressed this challenge by capitalizing on the triboelectric effect caused by friction between the gate and the insulating layer, yielding a compact low-power FET through structural



streamlining. However, persistent high-speed friction during device operation can cause rapid wear, compromising the device's longevity.

In response to the aforementioned issues, we introduce the air friction-driven rotating gate transistor (AFRGT), which is a groundbreaking concept in which the transistor is operated exclusively by the application of a drain voltage ( $V_D$ ) and proximity to a rotating component, without the requirement of an applied  $V_G$ . The AFRGT features a rotating gate that operates in a non-contact mode (to ensure wear resistance) combined with a slim, flexible form factor facilitated by low-temperature solution processing using organic semiconducting polymers. Notably, the harnessed energy is directly employable for powering purposes; however, the transistor itself possesses a streamlined design that only comprises three layers without any additional components, thereby reducing carbon emissions by simplifying future manufacturing processes. Crucially, the AFRGT dispenses with the conventional notion of a gate and operates by replacing  $V_G$  with harvested energy sources from the rotating tires of vehicles. This innovation is a breakthrough because it recycles energy expended during vehicle propulsion.

## RESULTS AND DISCUSSION

### Channel Formation Mechanism and Device Operation

The process underlying the amplification of the drain current ( $I_D$ ) within the proposed AFRGT is illustrated in Figure 2. The cross-sectional schematic of the device structure in Figure 2(a) provides a detailed description of the device. Notably, our investigation uncovered a multiple events, the first of which involved the appearance of a negatively charged surface on the rotating gate. As demonstrated in Figure 2(b), this intriguing phenomenon emerged due to the generation of triboelectric charges via the contact electrification between the surrounding polyimide (PI) covering and the aluminum wheel.<sup>41</sup> Notably, the spatial orientation of the rotating gate, including an intentional air gap, isolates the gate from the active layer of the device, as displayed in Figure 2(c). When the gate started rotating, a series of interactions occurred within the vicinity of the device. The gate was in frictional contact with microscopic airborne particles and induced negative charges on them, as depicted in Figures 2(d) and (e). The resulting phenomenon caused by this interaction is displayed in Figure 2(f) in which the negatively charged particles located within the air gap induce hole carriers within the adjacent active layer. This process gained momentum as the rotational speed of the wheel increased, ultimately forming a channel rich in hole carriers. Furthermore, as described in Figure 2(g), the

polarization of the substrate located beneath the active layer increases the electric field, emphasizing the overall dynamics of the process.

On applying a potential difference ( $V_D$  between the generated channels),  $I_D$  is amplified owing to the utilization of hole carriers, as shown in Figure 3(a). In the previously introduced rotating gate transistor, the gate was in direct frictional contact with the insulator, inducing charges within the adjacent active layer located on the opposite side. Drawing a parallel with this phenomenon, the AFRGT formed channels using the inductive influence of charges within the active layer owing to the friction with the air-gap insulator (i.e., non-frictional interaction). However, the fabricated AFRGT deviated (to an extent) from the standard behavior of conventional FETs. In conventional FETs, channels are formed via dielectric polarization by applying a voltage to the gate. In contrast, channel formation in the AFRGT is a consequence of the air friction exerted on the gate. Regardless of this distinction, the fabricated AFRGT manifested attributes similar to conventional FETs. For example,  $I_D$  amplification in the channel owing to the accumulation of charge carriers was discernible within the AFRGT. As demonstrated in Figure 3b, by applying a negative voltage to the drain electrode following the accumulation of holes within the poly(3-hexylthiophene-2,5-diyl) (P3HT) (which is a p-type semiconducting polymer) active layer, the Fermi level ( $E_F$ ) of the drain electrode increased, promoting an undisturbed flow of holes from the source electrode to the drain electrode.<sup>40,42</sup> This effect contributed to the overall efficacy of the AFRGT's amplification mechanism, enhancing the prospect of practical application.

Figure 4 presents the  $I_D$  in response to a gradually decreasing  $V_D$  from 0 to  $-20$  V through  $-5$  V being applied between the source and drain (S/D) electrodes. This investigation was conducted with the gate of the fabricated AFRGT in both rotational (driven) and stationary (non-driven) states. The time-dependent graph illustrates the obtained results. These measurements were recorded under the influence of two distinct gating conditions: a bare aluminum gate and a gate coated with PI. When the gate was non-driven, the  $I_D$  value corresponding to the applied  $V_D$  was consistent. However,  $I_D$  was distinctly amplified when the gate was driven. The AFRGT structure is inspired by the FET structure; however, unlike the ideal FET in which  $I_D$  is independent of  $V_D$  when the applied  $V_G$  is zero, the AFRGT operates as a metal-semiconductor-metal structure (which is a source-active layer-drain structure) without  $V_G$ . More specifically, prior to the onset of air friction, the  $I_D$  of the AFRGT depends on  $V_D$ . However, as illustrated in Figure 4, during gate rotation represented by the shaded region, the  $I_D$  of the AFRGT is amplified with respect to that under the gate-stopped condition, thereby resembling the application of  $V_G$  in a FET. Notably, these fluctuations were pronounced when the gate was coated with a PI layer, unlike when an uncoated aluminum gate was used. Notably, the bare aluminum gate

was not in contact with PI, indicating that it did not generate contact electrification by itself. Furthermore, static electricity is considerably weaker in metallic materials than in polymeric insulating materials.<sup>43</sup> Accordingly, PI exhibits a greater susceptibility to surface charge induction than aluminum, causing a substantial variation in  $I_D$ . Moreover, both variants of the device exhibited minimal variations in current at a  $V_D$  of 0 V.

### Substrate Influence on Current Amplification

To determine the physical significance of these current variations, we explored the impact of poly(vinylidene fluoride) (PVDF) substrate thickness on the device's operation. Figure 4 displays that all the measured  $I_D$  values are negative owing to the application of a negative  $V_D$ , considering the P-type active layer. However, as displayed in Figure 5, the variations in  $I_D$  ( $\Delta I_D$ ) are represented as positive because only the current amplified by the rotation of the gate is extracted and portrayed. Notably, the  $I_D$  of each device was averaged across multiple device fabrication and measurement iterations, minimizing any potential experimental discrepancies. In addition to the 50- $\mu\text{m}$ -thick PVDF substrate used in Figure 4, we incorporate PVDF substrates of varying thicknesses (10, 100, 150, and 200  $\mu\text{m}$ ). In contrast to the uncoated aluminum gate in Figure 4, all five device variants exhibited high  $\Delta I_D$  values when subjected to the rotation of the PI-covered gate. Moreover, the overall  $\Delta I_D$  reached saturation at  $-5$  V with minimal incremental enhancement at  $V_D$  values of  $-10$ ,  $-15$ , and  $-20$  V. Notably, excluding the thinnest substrate, which is 10  $\mu\text{m}$ , the devices with 50-, 100-, 150-, and 200- $\mu\text{m}$ -thick PVDF substrates exhibited increasing  $\Delta I_D$  as the substrate thickness decreased. In particular, the device with a 50  $\mu\text{m}$  PVDF substrate demonstrated the stands out  $\Delta I_D$  of 9.675 nA under a  $V_D$  of  $-20$  V. When other parameters remained constant and only the insulating layer thickness increased, the  $I_D$  could be reduced. The following formula delineates the relationship between  $I_D$  and insulator thickness ( $t_{ox}$ ) of a conventional FET:

$$I_{D(Sat)} = \frac{\mu W C_{ox} (V_G - V_T)^2}{2L},$$

$$C_{ox} = \frac{\epsilon_{ox}}{t_{ox}},$$

where  $I_{D(Sat)}$  is the  $I_D$  in the saturation region,  $\mu$  is the mobility,  $C_{ox}$  is the capacitance, and  $\epsilon_{ox}$  represents the dielectric constant.<sup>44,45</sup> In the proposed device configuration, the PVDF substrate functions as a secondary insulator after the primary air-gap insulator. This induces electric charges in the active layer via the polarization induced by the electric field, similar to the insulator's role in a traditional FET. Consequently,  $\Delta I_D$  increased as the PVDF substrate's thickness

decreased apart from a notable reduction in the case of the 10  $\mu\text{m}$  substrate. This phenomenon underscores that the PVDF insulator substrate in the device structure occupies the opposite side of the active layer where air friction occurs, unlike the conventional FET arrangement. Accordingly, the very thin insulator layers often result in charge-to-breakdown in conventional FETs.<sup>46–48</sup> Conversely, insufficient charge induction becomes prominent if the PVDF substrate in the AFRGT is excessively thin.

### Saturation Behavior and Dependence of Air-friction Distance

Figure 6(a) illustrates the  $\Delta I_D$  with respect to  $V_D$  across the voltage range of 0 to  $-5$  V, focusing on a device with a 50  $\mu\text{m}$  PVDF substrate. Evidently,  $\Delta I_D$  exhibited a pronounced surge starting at a  $V_D$  of approximately  $-1.5$  V, followed by a marked attenuation as the saturation point of the applied  $V_D$  ( $V_{D\text{sat}}$ ) approached  $-2$  V. This trend notably delineated the identifiable transitional regions, similar to the characteristic linear and saturation phases observed in conventional FETs. More specifically,  $I_D$  varied due to the channel created by induced and accumulated charges within the active layer.

To further investigate the dependence of air-gap distance on the air-friction-induced charges, a supplementary experiment is conducted, as shown in Figure 6(b). During the experiment,  $\Delta I_D$  was measured by incrementally adjusting the air gap between 0.5–100 mm while maintaining  $V_D$  at  $-20$  V. The results revealed a  $\Delta I_D$  of 10.57 nA at the minimal proximity of 0.5 mm with a logarithmic decline proportionate to the linear augmentation of distance that culminated in a minute  $\Delta I_D$  value of 0.08 nA at the maximum separation of 100 mm. Because the active layer was situated in proximity to the air-friction region, the active layer at the minimum distance exhibited a high efficiency in terms of charge induction from charged fine molecules. However, the efficiency of charge induction diminished as the physical distance from the air-friction region increased.

### Substrate Variability and Effect of the Absence of an Active Layer on Current Response

Extending our investigation beyond PVDF, we replicated the experiment and employed diverse substrate materials including glass, fluorinated ethylene propylene (FEP), and polydimethylsiloxane (PDMS). Figure 7 presents  $\Delta I_D$ -versus- $V_D$  graphs obtained from the devices with these alternative substrates. The device fabricated on a glass substrate exhibited the lowest  $\Delta I_D$  with a progressive escalation in the following sequence: FEP→PDMS→PVDF. This hierarchy was attributed to the dielectric constants and triboelectric polarities of the materials. Glass can be characterized by its dielectric constant of 6.7, and it is the second most polarizable among the four substrates

compared.<sup>49</sup> However, glass was on the positive side of the triboelectric series, rendering it relatively less responsive to charging when in contact with P3HT (the p-type semiconducting polymer active layer).<sup>50,51</sup> In contrast, the dielectric constants of PVDF, PDMS, and FEP are 10.2, 2.77, and 2.1, respectively.<sup>52-55</sup> Aligning with the triboelectric series, the  $\Delta I_D$  observed across devices incorporating these three substrates all exhibited negative polarity, which closely adhered to the hierarchy dictated by their respective dielectric constants.<sup>56,57</sup>

Figure 8 presents the  $\Delta I_D$  profiles of the proposed AFRGT device, without a P3HT active layer and subjected to varying  $V_D$  values of 0, -10, and -20 V. Across both plots of the bare aluminum and PI-covered gates, a minute current variation of approximately 2 pA was recorded when the gate rotation was stopped. Furthermore, the bare aluminum gate resulted in an  $\Delta I_D$  of approximately 320 pA during rotation, while the PI-covered gate yielded approximately 440 pA. These  $\Delta I_D$  values were minute with respect to the  $\Delta I_{DS}$  observed in previous intact AFRGT devices with active layers and could be attributed to leakage currents traversing the PVDF substrate. This finding substantiated the inference that the observed  $\Delta I_{DS}$  in all the analyzed AFRGT devices clearly signified that current was amplified through the active P3HT channel layer within the device.

### Verification through Practical Application

To evaluate the practical application potential of our fabricated AFRGT in real vehicle scenarios, we conducted an experiment employing the wheels of a radio control (RC) car, as shown in Figure 9. The figure displays the fabrication of the flexible AFRGT device on a PVDF substrate and affixing it to a rigid framework using electrical tape. This assembly provided a reliable platform for connecting the S/D electrodes in Figure 9(b). Subsequently, as presented in Figure 9(c), the framed device was fixed on the mud flap at an approximate distance of 1 mm from the tire of the RC car. A  $V_D$  of -20 V was then applied to the wire connected to the S/D electrodes allowing for  $I_D$  measurements. The dynamic motion of the RC car's wheel results in a fluctuating  $I_D$  profile, whereas the  $I_D$  maintains a consistent value when the wheel is stopped, as shown in Figure 9(d). This test confirmed the device's capacity to harness air friction-induced current from the moving tire of the car, proving its applicability in real-world vehicle scenarios.

### CONCLUSIONS

In this study, we introduced a novel AFRGT and conducted a comprehensive analysis of its operational principles and characteristics. Our investigation revealed the mechanism responsible for the amplification of  $I_D$  in the AFRGT,

different from conventional FETs. Specifically, we identified that the induction of hole carriers in the active layer was the pivotal process resulting in channel formation in the AFRGT. This was achieved through air-friction-driven interactions with the negatively charged surface generated through contact electrification of the rotating gate. Our findings underscore the distinguishing feature of the AFRGT, which eliminates the necessity for a  $V_G$  to amplify  $I_D$ . Instead, the device relies on the charge induction mechanism owing to air friction. Notably, within the context of a 50- $\mu\text{m}$ -thick PVDF substrate, only  $-20\text{ V}$  of  $V_D$  and proximity of 0.5 mm to the rotating component yielded a substantial variation in  $I_D$  (10.57 nA).

Although the presented AFRGT had the advantages of being a non-contact RGT and a gate-free transistor, the output electric current was relatively limited. Realizing the full potential of this innovative transistor technology requires further research and development. In future research, substantial improvements in current output are anticipated through straightforward approaches such as the application of semiconductor materials with high charge mobilities in their active layers instead of P3HT, substitution of insulating substrates with materials exhibiting higher  $\epsilon_{\text{ox}}$  than PVDF, or increasing the width/length ratio in the active-layer area. By positioning the proposed AFRGT near a rotating object, without any physical contact, the electric current can be amplified. Eliminating the need for a rotating component can simplify the fabrication process, which only comprises three steps in the entire solution process: the substrate, active layer, and S/D electrodes. This streamlined manufacturing process will allow for the fabrication of thin and flexible devices at low temperatures, facilitating a wide array of potential applications. Moreover, the simple structure and low-temperature solution processing of this technology will yield significant environmental benefits by conserving energy resources required for material fabrication and vacuum processes. Additionally, the inherent wear-resistant characteristics through non-friction will confer permanence to the device, resulting in cost savings related to production. Furthermore, the AFRGT aligns with the concept of sustainable development by harvesting and utilizing the energy expended by rotating tires during the straightforward movement of vehicles.

Significantly, our experimental results involving the wheels of an RC car provided substantial evidence of the AFRGT's feasibility. The device adeptly harnessed electric current generated through air friction from moving tires, demonstrating its practicality and applicability in real-world environments. This underscores the promising prospects of AFRGT technology across diverse domains ranging from electronics to vehicle systems with considerable interests and potential for future innovation. Moreover, various applications of this technology extend beyond the integration

of current amplifiers and switches to harness external aerodynamic forces during vehicular and aviation operations. The AFRGT can also be employed as a power-assist device by storing amplified currents.

### **Limitations of the Study**

Because the P3HT layer is delicate and thin, experiments involving rotating the gate directly with the P3HT film with a bottom electrode were not conducted. Opting for a resilient and robust active layer may effectively address the inherent output performance of the rotating TENG. This approach allows for the quantification of the equivalent gate voltage. Since our AFRGT is fabricated from polymer materials, temperature variations can influence the material itself, leading to changes in its properties. Furthermore, our measurement equipment faces challenges in measuring below the  $\sim$  nA level, and the output current of our device is at the  $\sim$ nA level. Thus, despite conducting experiments at low speeds to extract data, measuring the anticipated gradual changes proved to be insufficient. We aim to develop an improved AFRGT through future advanced research moving forward, achieving enhanced robustness and output performance. This will enable us to test the device under various speed and temperature conditions.

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### **Author contributions**

H.S.: Conceptualization, Methodology, Validation, Formal analysis, Investigation, Resources, Data Curation, Writing - Original Draft, Writing - Review & Editing, Visualization, Supervision, Project administration. D.Y.K.: Conceptualization, Resources, Writing - Review & Editing, Supervision, Funding acquisition,

### **Declaration of interests**

The authors declare no competing interests.

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### Figure 1. Schematic overview of the fabricated AFRGT

The fabricated AFRGT featuring a cylindrical aluminum gate with a polyimide surface. The rotating gate is positioned at an air gap distance from the active layer and rotates along the path indicated by the red dotted arrow.

### Figure 2. Schematic diagrams showing the mechanism of channel formation within the fabricated AFRGT

(a) Cross-sectional schematic of the device structure, (b) generation of triboelectric charges due to the presence of aluminum with covered polyimide surface, (c) configuration of the rotating gate and the main body of the AFRGT with an air-gap distance, (d) friction interactions with microscopic airborne particles within the air gap as the gate initiates rotation in the direction indicated by the orange arrow, (e) negatively charged particles influenced by polyimide, (f) induction of negatively charged particles resulting in the majority carriers in the active layer on the surface, and (g) an insulating substrate polarization facilitating hole-carrier accumulation.

### Figure 3. Schematic diagram of drain current owing to holes

Schematic diagram depicting the flow and amplification of drain current when a drain voltage is applied to both ends of the channel established within the active layer of (a) an AFRGT and (b) a conventional FET when a gate voltage is applied. (c) Energy level diagram between the source and drain electrodes when the drain voltage is below zero for the P-channel transistors in both the AFRGT and conventional FET. Holes migrate along the path indicated by the red-dotted arrow.

### Figure 4. Output characteristics of the AFRGT

The AFRGT with (a) a bare aluminum gate and (b) a polyimide-covered gate under both stopped and rotating conditions. Drain current variations over time are observed under various drain voltage regulations ( $V_D = 0, -5, -10, -15, \text{ and } -20 \text{ V}$ ). The regions shaded in yellow correspond to gate rotation (i.e., driving), whereas the unshaded regions represent gate stopped (non-driven).

### Figure 5. Variation in drain current for different PVDF substrate thicknesses

Variation in drain current according to drain voltage in the AFRGT (10, 50, 100, 150, and 200  $\mu\text{m}$ ) employing (a) a bare aluminum gate and (b) a polyimide-covered gate. The black squares denote variations in drain current recorded

during gate immobility, whereas the red circles represent measurements recorded during gate rotation. The rightmost graph contains the statistics for different thicknesses.

**Figure 6. Drain current variations in the AFRGT with a 50  $\mu\text{m}$  substrate**

Curves demonstrating the variations as (a) the applied drain voltage gradually reduces from 0 to  $-5$  V and (b) the air-gap distance progressively increases from 0.5 to 100  $\mu\text{m}$ .

**Figure 7. Variations in the drain current of to the AFRGT with glass, FEP, PDMS, and PVDF substrates**

Variations in the drain current in response to drain voltage applied to the AFRGT under both stopping and rotating conditions: (a) bare aluminum gate and (b) polyimide-covered gate. The rightmost graph contains the statistics for different thicknesses.

**Figure 8. Variations in drain current of the ARGV with no active layer**

(a) an uncovered bare aluminum gate and (b) a polyimide-covered gate.

**Figure 9. Procedure for validating the feasibility of using the current amplified from a tire of an RC car.**

(a) Photograph of the actual AFRGT device enclosed within the square dotted outline. (Insets: Dotted arrows and structural schematics for part identification, as well as photographs showcasing the flexibility of the fabricated device). (b) Image of the flexible AFRGT securely affixed to a rigid frame for electrode connections and attachment, and (c) this frame subsequently attached with an air gap to a tire of an RC car. (d) Graph depicting drain current over time, alongside (e) and (f) actual photographs captured when the RC car is in motion and at rest. The demonstration video is available in the Supplemental Information (see Video S1 and S2).

**STAR METHODS**

**KEY RESOURCES TABLE**

REAGENT or RESOURCE	SOURCE	IDENTIFIER
Chemicals, peptides, and recombinant proteins		



PDMS	Sewang Hitech Silicone	Sylgard 184
P3HT	Rieke Metals	Cat#4002-EE
PVDF	Sigma-Aldrich,	CAS: 24937-79-9
Ag paste	ELCOAT	P-100
DMF	Sigma-Aldrich	CAS: 68-12-2
Cloroform	Sigma-Aldrich	CAS: 67-66-3
Software and algorithms		
OriginPro 8.5	OriginLab Corporation	<a href="https://www.originlab.com/">https://www.originlab.com/</a>
Other		
Keithley 2636 SourceMeter	Tektronix Technologies	<a href="https://www.tek.com/">https://www.tek.com/</a>
Slide glass	Marienfeld	<a href="https://www.marienfeld-superior.com/">https://www.marienfeld-superior.com/</a>
FEP film	BOLA	<a href="https://www.bola.de/">https://www.bola.de/</a>

## RESOURCE AVAILABILITY

### Lead contact

Further information and requests for resources and materials should be directed to and will be fulfilled by the lead contact, Dae Yu Kim (dyukim@inha.ac.kr).

### Materials availability

This study did not generate new unique materials.

### Data and code availability

- This paper analyzes existing, publicly available data. These accession numbers for the datasets are listed in the key resources table.
- This paper does not report original code.
- Any additional information required to reanalyze the data reported in this paper is available from the lead contact upon request.

## METHOD DETAILS

Figure 1 depicts a top-contact transistor featuring an aluminum rotating gate covered with a polyimide film. The rotating gate is situated 1 mm away from the P3HT active layer in which the air gap serves as the insulating layer in the transistor structure.

### Preparation of the Device Substrates

Among the various types of AFRGT substrates, PVDF was prepared as follows. Initially, PVDF in the powder form (Sigma-Aldrich, Mw ~534,000) was mixed with N,N-Dimethylformamide (DMF, Sigma-Aldrich) at a concentration of 5 wt% and then dissolved using a sonicator for 10 min. The resulting solution was then poured onto a slide glass and annealed at 100 °C for 30 min on a hot plate to produce a flat PVDF substrate. For the PDMS substrate, Sylgard 184A was mixed with a curing agent (Sylgard 184B) in a 10:1 wt. ratio and stirred at 250 rpm for 10 min at room temperature. The solution was then applied to a slide glass and annealed at 100 °C for 30 min to form a flat PDMS substrate. The slide glass (Marienfeld) and FEP film (BOLA) were ultrasonically cleaned with acetone, isopropyl alcohol, and deionized water, after which the substrates were used as the glass and FEP substrates, respectively.

### Fabrication of the AFRGTs

A 5 wt% solution of P3HT (Rieke Metals) dissolved in chloroform was drop-cast onto the prepared substrates, followed by thermal curing at 90 °C for 30 min. Subsequently, silver paste was applied to both top edges of the P3HT layer to serve as the S/D electrodes, resulting in a square active layer with a channel width (W) and length (L) of 17 mm. A rotating gate consisting of a polyimide-covered aluminum wheel with a width of 17 mm and a smooth surface was affixed to a motor and positioned at a 1 mm distance from the active layer of the AFRGT. This setup effectively replaced the conventional application of the gate electrode and  $V_G$ .

### Measurement and Characterization

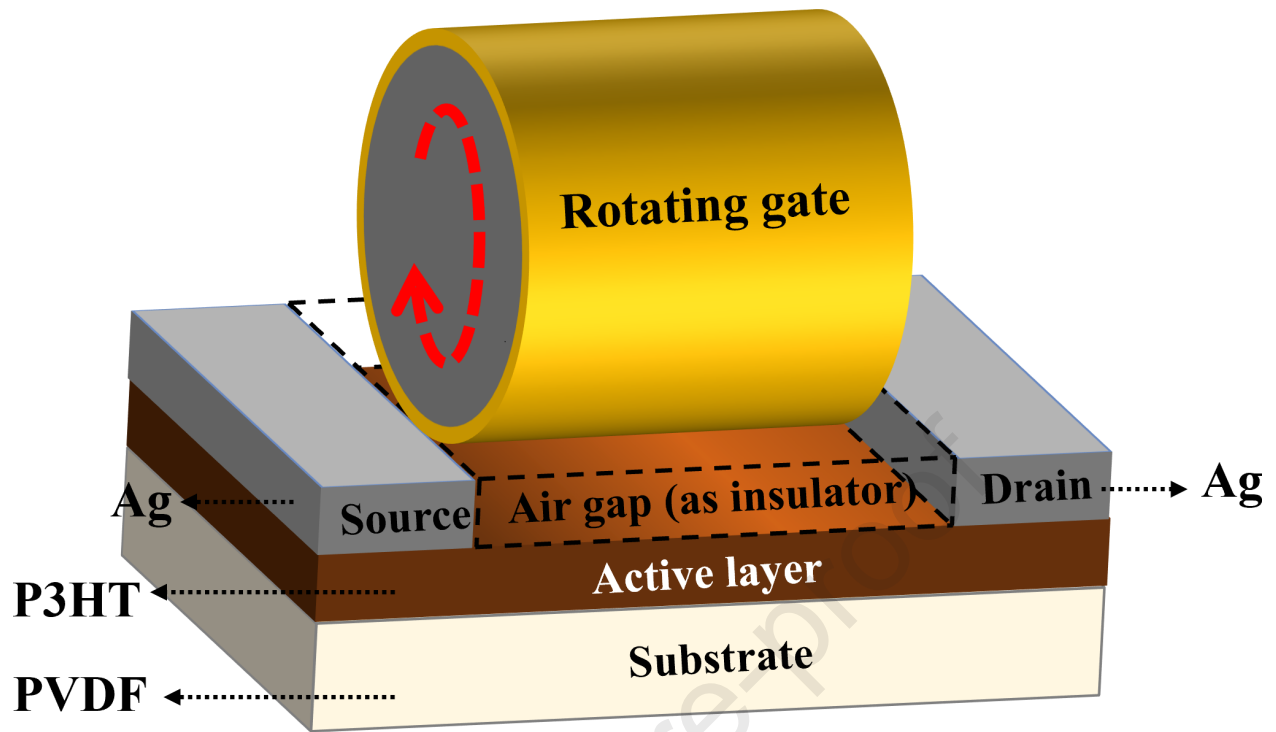
To assess the electrical characteristics of the fabricated AFRGT, we examined the  $I_D$  while the gate was rotated at a speed of 2200 rpm by a fixed motor, following the application of  $V_D$  between the S/D electrodes using the Keithley 2636 SourceMeter. To ensure that the observed drain current was generated by the rotating gate, we compared the drain current obtained under this rotational state to that obtained when the motor was stopped. This comparative analysis proved that the rotating gate was actively influencing the output current.

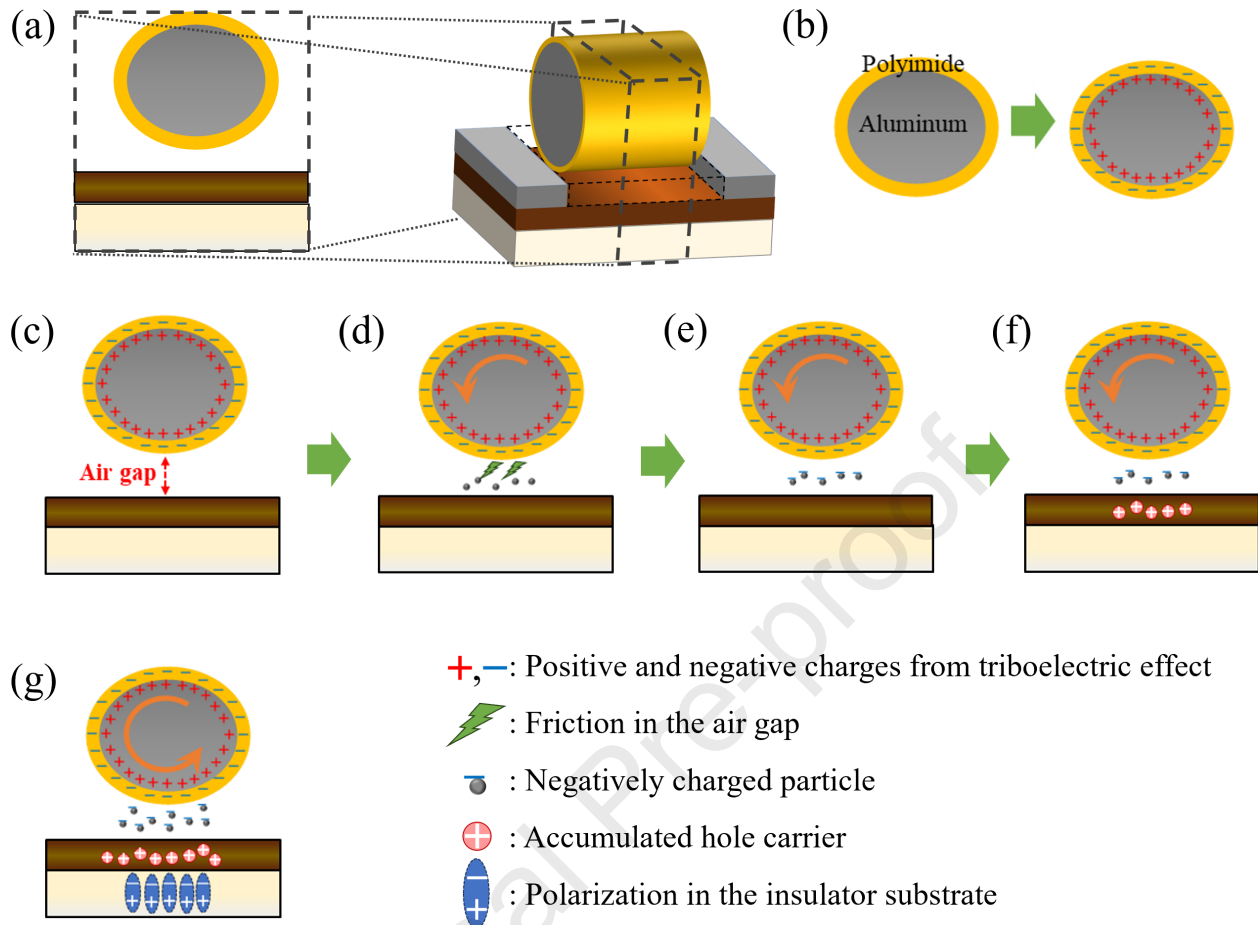
**Supplemental Information**

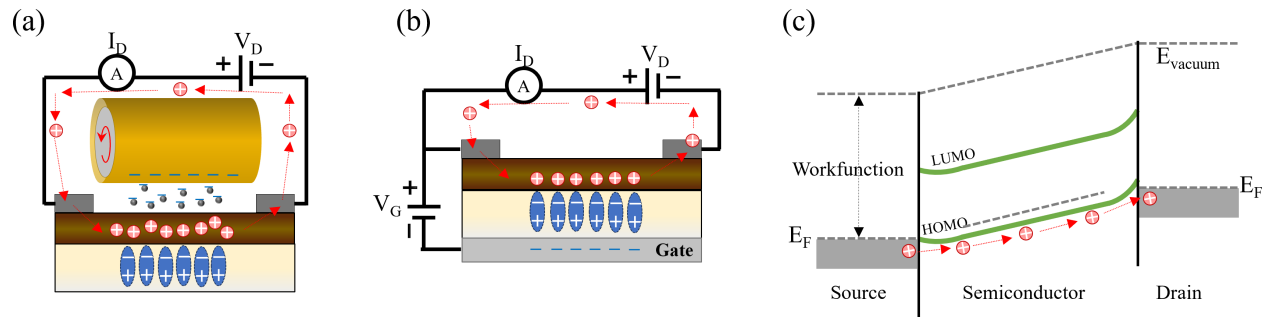
**Video S1.** The fluctuation of the drain current profile during forward, reverse, and stop motions of the RC car with a drain voltage of  $-20$  V in Figure 9.

**Video S2.** The procedure for measuring drain current amplification during the swift rotation of RC car wheels under drain voltage conditions of  $-20$  V or  $0$  V in Figure 9.

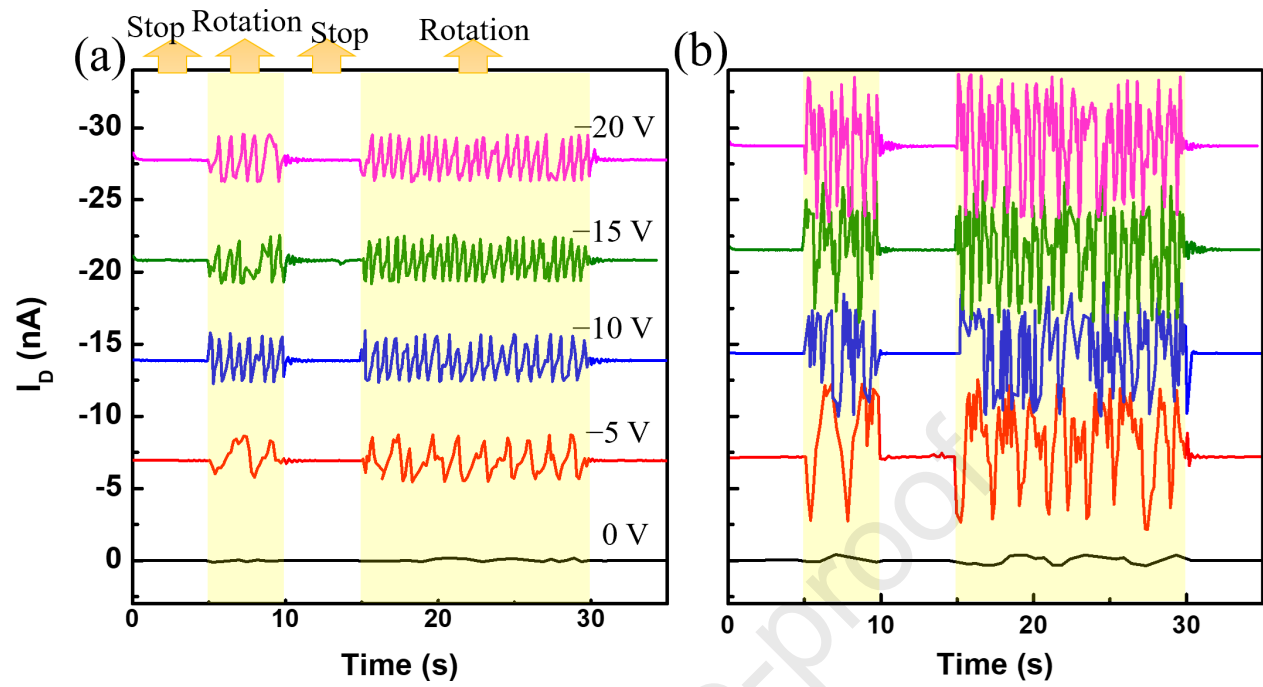
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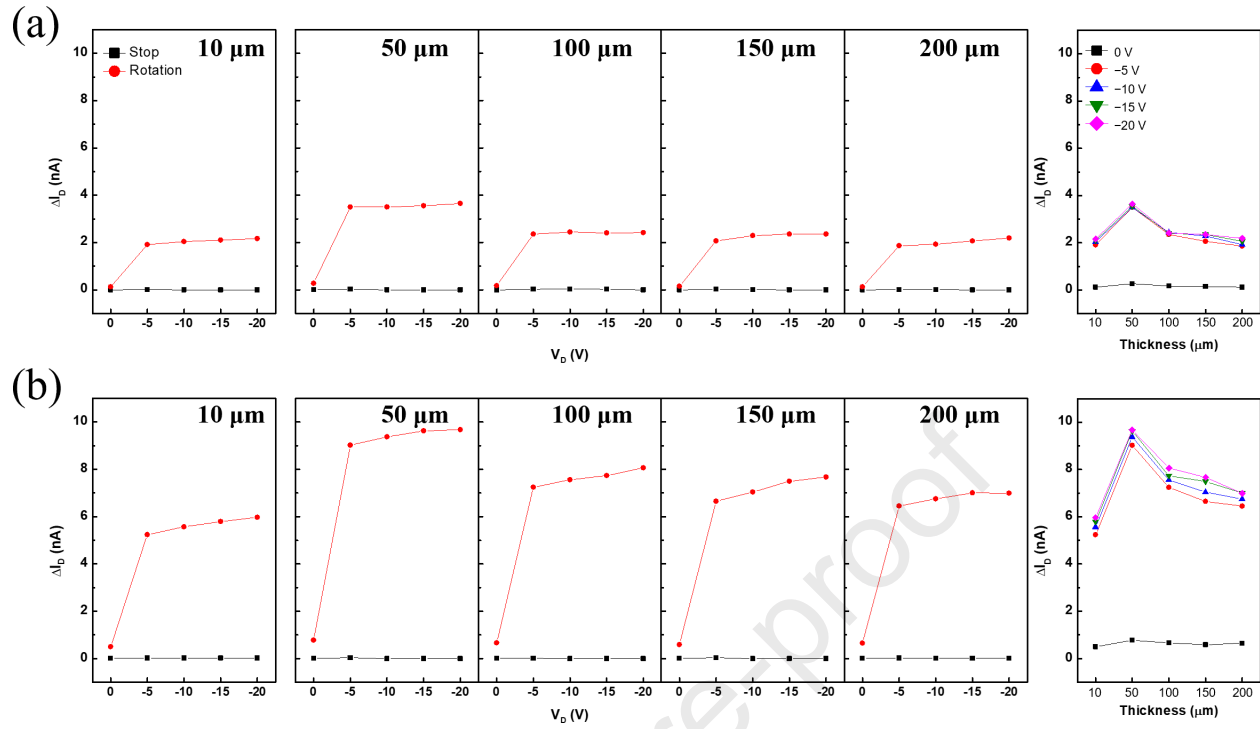




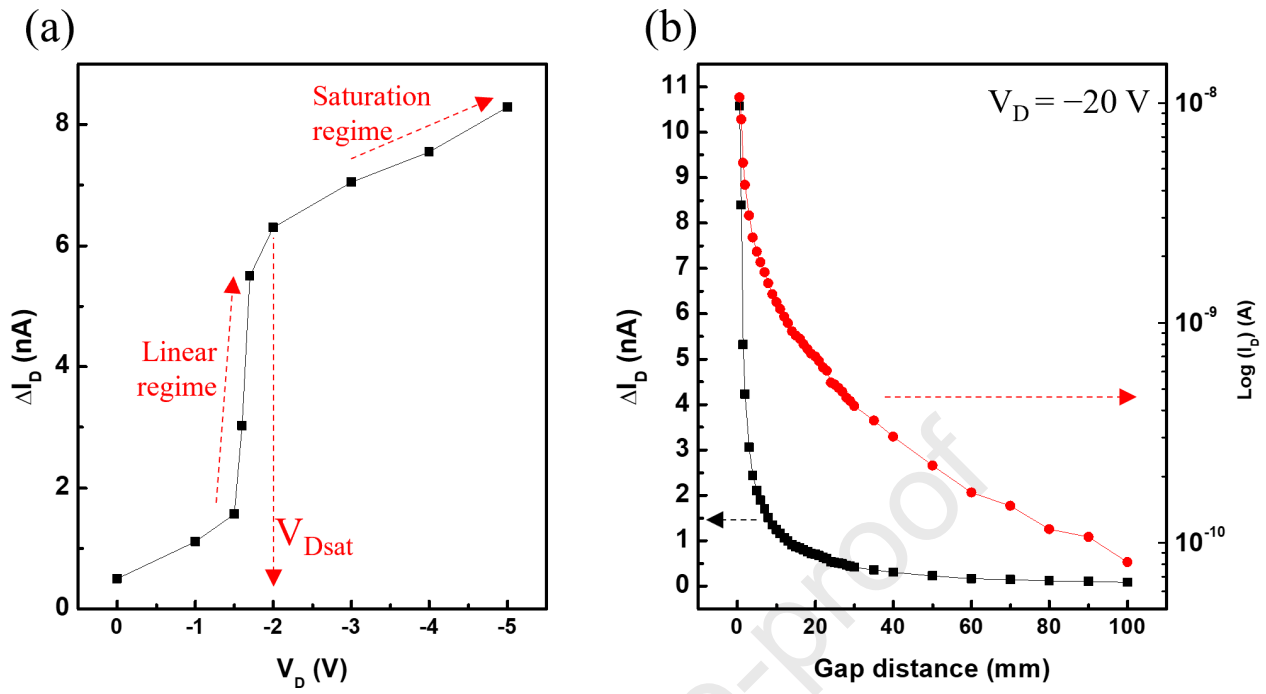


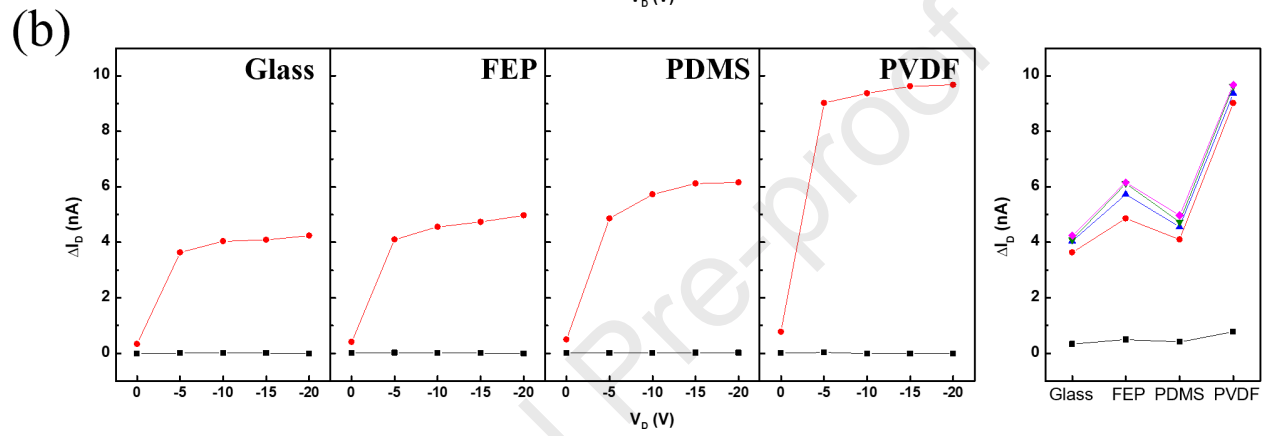
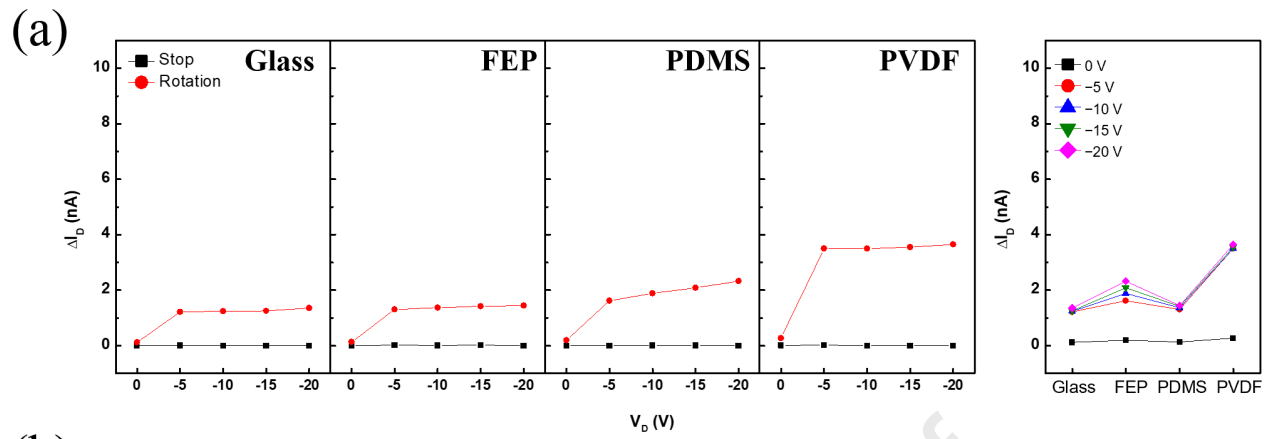
Journal Pre-proof

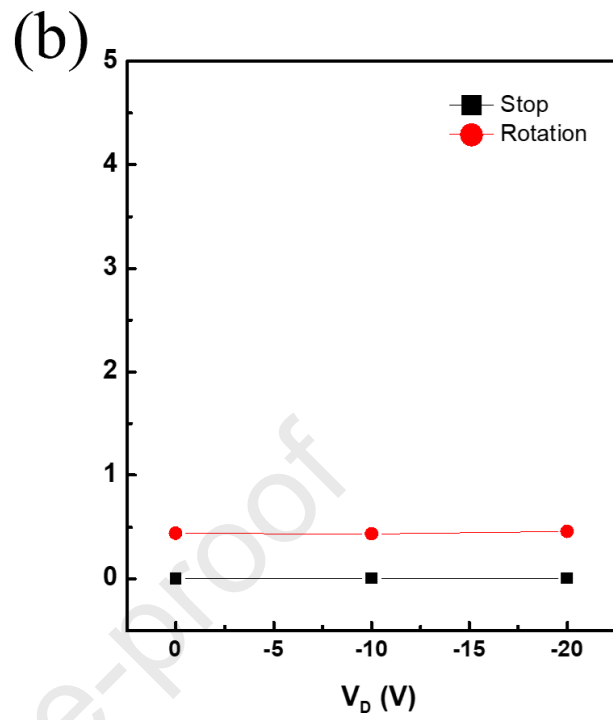
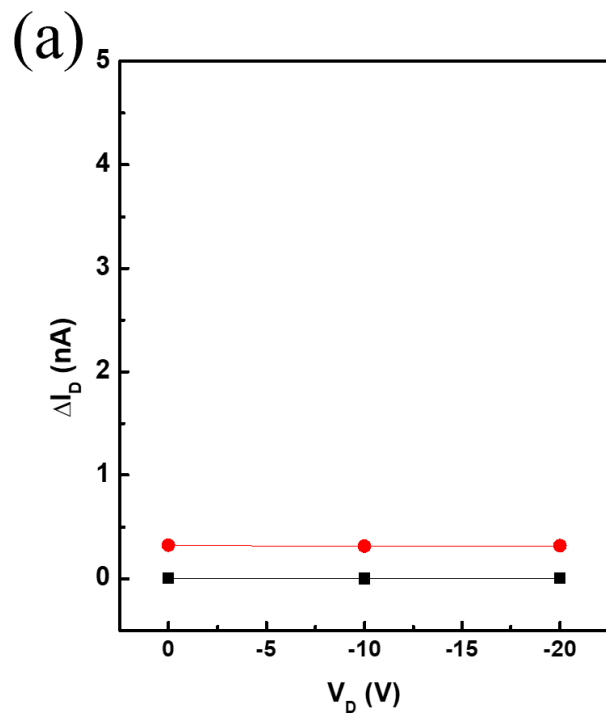


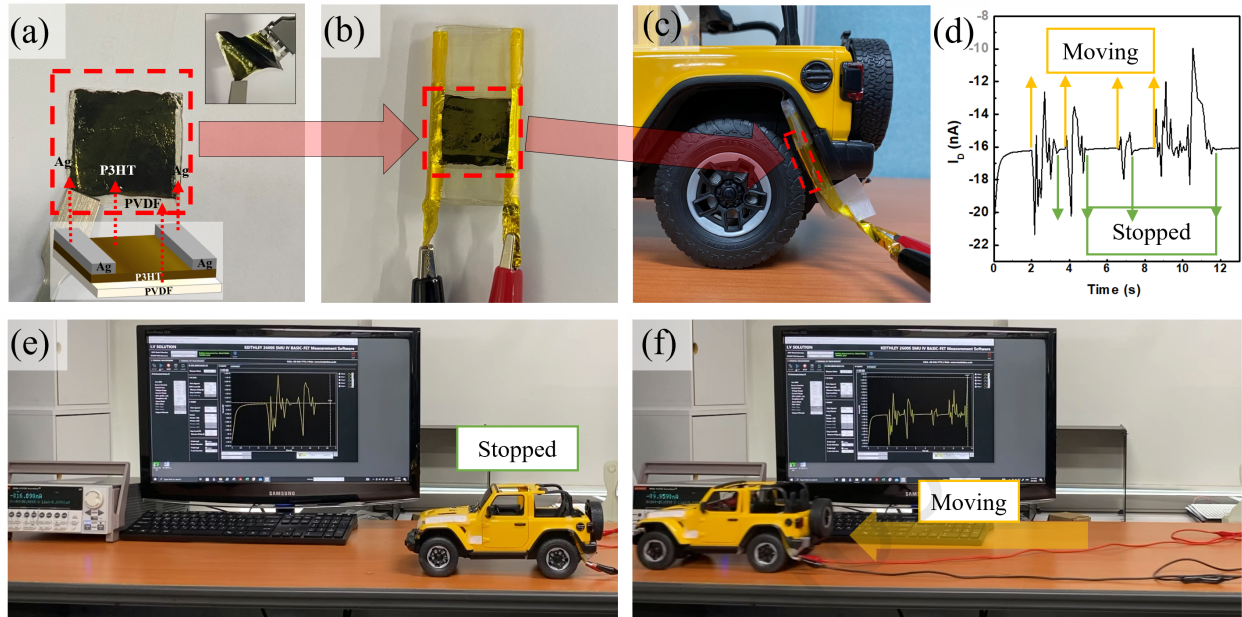












## Highlights

- An innovative transistor operating without a gate voltage
- Wear-resistant, slim, and flexible with low-temperature processing
- Simplified three-layer structure reduces carbon emissions in manufacturing
- Harvests energy from vehicle tires, conveyor belts, or any moving part

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